

Electronic Information Disclosure Statement

SEMICONDUCTOR WITH CONTACT AND RELATED METHODS

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Confirmation:

Applicant(s): Toshiharu Furukawa

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US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Citation No.	Patent Number	Date	Bar Code	Patentee	Class	Subclass
	P01	6316311	2001-11-13		Chen		
	P02	6294449	2001-09-25		Wu et al.		
	P03	6281143	2001-08-28		Huang et al.		
	P04	6274471	2001-08-14		Huang		
	P05	6274468	2001-08-14		Hsu		
	P06	6271108	2001-08-07		Choe		
	P07	5997757	1999-12-07		Nagayama et al.		
	P08	5928969	1999-07-27		Li et al.		

	P09	5899742	1999-05-04		Sun
	P10	5792703	1998-08-11		Bronner et al.
	P11	5691561	1997-11-25		Goto
	P12	5464793	1995-11-07		Roehl

Signature

Examiner Name	Date